

Title (en)

Method of and apparatus for preparing oxide superconducting film.

Title (de)

Verfahren und Vorrichtung zur Herstellung von dünnen Schichten aus supraleitendem Oxyd.

Title (fr)

Procédé et dispositif pour la fabrication de couches minces d'oxyde supraconducteur.

Publication

EP 0444698 A2 19910904 (EN)

Application

EP 91103103 A 19910301

Priority

- JP 3040391 A 19910225
- JP 5252290 A 19900302
- JP 5252390 A 19900302
- JP 5252490 A 19900302

Abstract (en)

In order to enable formation of a smooth and dense oxide superconducting film with no clear appearance of grain boundaries in a fine structure even at a high film forming rate, a laser ablation method is employed to apply a laser beam 2 to a target 1 containing components of an oxide superconductive material and deposit particles, which are thus scattered from the target 1, on a substrate 3, while gaseous oxygen is supplied from a gaseous oxygen inlet 7 toward laser plasma 6, which is generated by the application of the laser beam 2. <IMAGE>

IPC 1-7

H01L 39/24

IPC 8 full level

C01B 13/14 (2006.01); **C01G 1/00** (2006.01); **C01G 3/00** (2006.01); **C23C 14/00** (2006.01); **C23C 14/08** (2006.01); **C23C 14/28** (2006.01); **C23C 14/34** (2006.01); **C30B 23/08** (2006.01); **C30B 29/22** (2006.01); **H01B 12/06** (2006.01); **H01B 13/00** (2006.01); **H01L 39/24** (2006.01)

CPC (source: EP US)

C23C 14/0021 (2013.01 - EP US); **C23C 14/087** (2013.01 - EP US); **C23C 14/28** (2013.01 - EP US); **H10N 60/0521** (2023.02 - EP US); **Y10S 505/73** (2013.01 - EP US); **Y10S 505/732** (2013.01 - EP US); **Y10S 505/786** (2013.01 - EP US)

Cited by

EP0568446A1; DE4340752A1; US5622567A; US5760366A; US6033741A; US6110291A

Designated contracting state (EPC)

DE FR GB

DOCDB simple family (publication)

EP 0444698 A2 19910904; **EP 0444698 A3 19910925**; **EP 0444698 B1 19950118**; CA 2037432 A1 19910903; CA 2037432 C 19980922; DE 69106742 D1 19950302; DE 69106742 T2 19950907; JP 3192666 B2 20010730; JP H04214007 A 19920805; US 5187148 A 19930216; US 5300485 A 19940405; US 5334252 A 19940802

DOCDB simple family (application)

EP 91103103 A 19910301; CA 2037432 A 19910301; DE 69106742 T 19910301; JP 3040391 A 19910225; US 66287491 A 19910301; US 95196792 A 19920925; US 95292892 A 19920925